

**Form PTO-1449**  
(SNL-Modified)  
(9/94)

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

(37 CFR 1.98(b))

ATTY. DOCKET NO.  
SD6957S97604

SERIAL NO.  
09 /

APPLICANT  
Clews et al

FILING DATE

12/5/01

GROUP

11002 U.S. PTO  
10/010850  
12/05/01

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE
BT	1	4,009,115	2/22/77	Binns	252	142	8/25/75
BT	2	4,370,173	1/25/83	Dollman	134	3	4/30/82
BT	3	4,959,105	9/25/90	Neidiffer	134	3	3/14/90
BT	4	5,824,601	10/20/98	Dao	438	713	6/30/97

**FOREIGN PATENT OF PUBLISHED FOREIGN PATENT APPLICATION**

		DOCUMENT NUMBER	PUBLICATION DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

**OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)**

BT	1	J. Buhler, F.-P. Steiner and H. Baltes, "Silicon Dioxide Sacrificial Layer Etching in Surface Micromachining," <u>Journal of Micromechanics and Microengineering</u> , vol. 7, pp. R1 - R13, 1997.
BT	2	P.T.J. Gennissen and P.J. French, "Sacrificial Oxide Etching Compatible with Aluminum Metallization," <u>Proceedings of the 1997 International Conference on Solid-State Sensors and Actuators, Transducers '97</u> , pp. 225-228, 1997.
BT	3	J.F.L. Goosen, B.P. van Driehhuizen, P.J. French and R.F. Wolffenbuttel, "Problems of Sacrificial Etching in the Presence of Aluminum Interconnect," <u>Sensors and Actuators A</u> , vol. 62, pp. 692-697 (1997).

EXAMINER

Binh Tran

DATE CONSIDERED

2/7/03

<b>Form PTO-1449</b> (SNL-Modified) (9/94)  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>  (37 CFR 1.98(b))		ATTY. DOCKET NO. SD6957S97604	SERIAL NO. 09 /
		APPLICANT Clews et al	
		FILING DATE	GROUP
<b>OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)</b>			
BT	4	L. Archer and S.-A. Henry, "Removing Potash Polymer Residue from BEOL Structures Using Inorganic Chemicals," <u>Micro</u> (micromagazine.com), pp. 95-103, June 2001.	
BT	5	"Reidel-de Haen Electronic Chemicals of Semiconductor Grade," (www.sigmaaldrich.com/saws.nsf/Pages/fl_newproducts_sp3?OpenDocument) pp. 1-4, November 28, 2001.	
EXAMINER		DATE CONSIDERED	
Binh Tran		2/7/03	